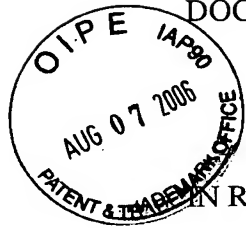


DOCKET NO.: 251323US6YA



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

Eric J STRANG

SERIAL NO: 10/813,115

GROUP: 1762

FILED: March 31, 2004

EXAMINER:

FOR: METHOD AND SYSTEM FOR PERFORMING ATOMIC LAYER
DEPOSITION

LETTER

Mail Stop DD
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Submitted herewith is an International Search Report and Written Opinion for the Examiner's consideration. The reference(s) listed therein have been cited in the U.S. Office Action dated June 29, 2006.

Respectfully Submitted,

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